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(54) **Turbomolecular pump**

Turbomolekularpumpe

Pompe turbomoléculaire

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- **PATENT ABSTRACTS OF JAPAN vol. 14, no. 3 (M-915)(3946) 8 January 1990 & JP-A-01 253 590 (AISIN SEIKI CO)**

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Description

The invention relates to vacuum apparatus and, more particularly, to turbomolecular pumps used for producing a vacuum in vacuum chambers.

Vacuum processes are used widely in semiconductor, optics, and other fields of industry. For example, in the electronics industry, a vacuum process is used in the physical vapor deposition (PVD) method of fabricating thin film conductors. Such thin films are principally fabricated through physical deposition of metals upon various substrate materials. One such PVD technique used in fabricating metallic thin films is a sputtering method. In general, the sputtering method involves accelerating, by means of electrical discharges, argon (Ar+) and other ionic elements in a vacuum. The accelerated ions collide with a negative potential electrode (target). The material comprising the electrode escapes from the surface thereof by receiving the energy of the argon (Ar+) ions (in a phenomenon called "sputtering"), and the substance escaping the electrode deposits itself on a substrate. The result is the formation of a metallic thin film on the substrate.

Such sputtering equipment is typically enclosed in a vacuum chamber. As such, the transformation of the thin-film substance from the electrode into highly energetic ions occurs in a vacuum. Consequently, an evacuation or vacuum apparatus is necessary in order to substantially eliminate any gas from the vacuum chamber within which the sputtering process is accomplished. Conventionally, either a cryogenic pump (cryo-pump) or a turbomolecular pump (turbo-pump) containing a cold trap panel is used for this purpose.

With reference to FIG. 10, the following is a description of a cryo-pump system 100 that uses a helium gas refrigerator to cool the pump. In this illustrative cryo-pump system, the cryo-pump 112 is attached by a duct 108 to a vacuum chamber 106 through a main valve (high-vacuum valve) 110. The cryo-pump 112 is connected to a rotary pump (a mechanical pump) 118 through a cryogenic rough valve 114. The rotary pump is used to initially create a partial vacuum (also known as a low or rough vacuum) in the chamber and the cryo-pump is used after the partial vacuum is created to further evacuate the chamber. A rough evacuation duct 120 connects the vacuum chamber 106 to a duct 116 that links the cryogenic valve 114 to the rotary pump 118. A chamber rough valve 122, located in duct 120, controls flow therethrough. Another duct 104 protrudes from the vacuum chamber 106, and a chamber vent valve 102 is provided at a point along this duct.

Operation of such a cryo-pump system is complex and time consuming. Specifically, to produce a vacuum in vacuum chamber 106, the cryo-pump system must perform the following steps: (1) the chamber vent valve 102, main valve 110, and cryogenic rough valve 114 are closed; (2) the chamber rough valve 122 is opened; (3) the rotary pump 118 is then activated in order to perform a rough evacuation of the vacuum chamber 106; (4) the chamber rough valve 122 is closed; (5) main valve 110 is opened; and (6) the cryo-pump 112 is activated in order to perform a secondary evacuation of the vacuum chamber 106. The secondary evacuation produces a sufficient vacuum in the vacuum chamber that facilitates use of a sputtering process therein.

FIG.11 depicts a conventional cryo-pump 112 as used in the cryo-pump system described above. Cryo-pump 112 contains a rotational axis 204 that is connected at one end to a small helium-gas refrigerator (not shown). Another end of the rotational axis 204 enters into a pump case 206. At the tip of the axis is a cold vane 202. A baffle 200 is provided at the inlet of the pump case 206. The duct 108 is connected to the periphery of an inlet 208.

In the cryo-pump 112, the baffle 200, the cold vane 202, and other components are maintained at a cryogenic temperature, i.e., a temperature at which molecules are adsorbed by the baffle, cold vane and other cold components of the cryo-pump. Of the gas molecules that enter inlet 208 through the duct 108, water vapor and any other elements and molecules that have a vapor pressure higher than that of water are condensed upon the baffle 200. As such, these molecules and elements are eliminated from the vacuum chamber. Other gasses, such as nitrogen, oxygen, and argon, whose vapor pressure is lower than the vapor pressure of water, adhere to the cold vane 202. Gases of even lower vapor pressures are adsorbed by a cold panel (not shown),

These gases are then conventionally captured by respective adsorption agents.

Detrimentally, a cryo-pump requires a relatively long startup time, i.e., until the pump is cooled to a prescribed cryogenic temperature, and a relatively long shutdown time, i.e., until the temperature of the pump rises to a prescribed temperature. Generally, the startup and shutdown times are each on the order of one to two hours. During the shutdown time, to ensure that the adsorbed gasses do not evaporate and enter the vacuum chamber, the vacuum chamber must remain sealed and connected to the cryo-pump. Thus, to enable isolation of the cryo-pump from the vacuum chamber and permit access to the chamber shortly after processing within the chamber is completed, the main valve is provided between the cryo-pump and the vacuum chamber. As such, once the sputtering process is complete, the main valve is closed and the vacuum chamber can be brought to atmospheric pressure. Thus, workers can have access to the chamber without waiting for the cryo-pump to warm, i.e., without waiting the shutdown period. Furthermore, by using a main valve, the cryo-pump can be warmed in isolation from the vacuum chamber such that the water vapor and other contaminants previously captured by the pump do not evaporate from the cryo-pump and enter the vacuum chamber.

However, use of such a main valve has certain

drawbacks. Typically, the main valve is a high-vacuum bellows valve or other similar-type high vacuum valve. As such, the large pressure difference between the high-vacuum side and the atmospheric side, and the need for airtight sealing, make the structure of the main valve necessarily complex. Consequently, the structural complexity of the main valve, increases the surface areas of the valve components. Because the valve operates in a high vacuum, the dust accumulated on the surfaces of these components creates, within the vacuum chamber, a potential particle contamination problem. Also, gases emanate from the constituent materials of the valve components, i.e., outgassing. These gases flow into the vacuum chamber and detract from the creation of a high vacuum. Therefore, an ideal solution, from the standpoint of ensuring a high vacuum in the vacuum chamber, is elimination of the main valve between the vacuum chamber and the cryo-pump. However, it is not possible to eliminate the main valve from the type of vacuum pump system of FIG. 10 without risking contamination of the vacuum chamber during shutdown (warming) of the cryo-pump.

In an attempt to eliminate the use of a main valve in a vacuum system, those skilled in the art have turned to using turbomolecular pumps (turbo-pumps) rather than cryo-pumps. An illustrative vacuum system that uses a turbo-pump 300 having a cold trap panel 318 is depicted in FIG. 12. The cold trap panel, which is provided at the inlet 323, is designed to adsorb water molecules much like the baffle in a cryo-pump adsorbs water molecules. In this turbo-pump, a shaft 306, to which an impeller 310 is attached, is contained in the pump case 302. The shaft forms a main axis of rotation for the impeller. The shaft 306 is supported by top and bottom touchdown bearings 304 and a motor magnet bearing 308 (a portion of electric motor 324). At the bottom of the pump case 302 is an exhaust vent 312. A cold panel casing 314 is attached to the periphery of the inlet for the pump case 302. The cold trap panel 318, protected by a cover 316, is provided inside the cold panel casing 314. To reduce the temperature of the cold trap panel, a cooling medium pipe 320 linked to a refrigerator (not shown) is attached to the cold trap panel 318. A duct 322, which carries the contaminants from the vacuum chamber, is connected to the cold panel casing 314.

In the turbo-pump 300, the gaseous molecules entering the pump via the inlet to the pump case undergo compression by the high-speed rotation of the impeller 310 and are discharged through the exhaust vent 312. During this process, the gaseous molecules entering from the inlet 323 are cooled by the cold trap panel 318 such that only the water molecules, which constitute the predominant proportion of the gas residues remaining in the vacuum chamber to which the turbo-pump is connected, are adsorbed onto the cold trap panel. Therefore, the evacuation span of the water molecules freezing on the trap panel is considerably longer than in the case of a cryo-pump. This permits the selective and continuous evacuation operation of the turbo pump.

In a turbo-pump system, excessive accumulation of water molecules on the cold trap panel impedes the effectiveness of the panel to further trap water molecules. Therefore, periodically and between uses of the vacuum chamber, a turbo-pump with a cold trap panel requires vaporization of the water molecules presently adsorbed by the trap. Typically, vaporization is accomplished by allowing the cold trap panel to warm to room temperature while rotating the impeller such that vaporized water molecules are drawn into the pump and not permitted to enter the vacuum chamber. Thus, prior to venting the interior of the vacuum chamber to atmospheric pressure, the temperature of the cold trap panel is raised from a cryogenic temperature, e.g., the temperature at which water molecules can be adsorbed, approximately 100 degrees Kelvin, to approximately room temperature, e.g., 300 degrees Kelvin. Such warming (shutdown time) requires about one hour to accomplish.

Although, such a turbo-pump vacuum system can be used without a main valve, to enable the vacuum chamber to be entered prior to fully warming the cold trap panel, a main valve is used to isolate the vacuum chamber from the turbo-pump. Such a configuration, therefore, is susceptible to problems of dust and gas generation from the main valve, as in the case of a cryo-pump.

Furthermore, the turbo-pump depicted in FIG. 12 suffers from the disadvantage that the cold trap panel located at the inlet of the pump case substantially reduces the effective suction area of the inlet, i.e., the cold trap panel partially blocks the inlet. Consequently, the location and shape of the trap panel reduces the conductance of the pump, thus decreasing the performance of the turbo-pump.

Document US-A-3 625 019 discloses a turbomolecular vacuum pump having a cylindrical casing with at least two large openings therein, one attached to or adapted form connection to a vessel to be evacuated and the other for providing access to a cold trap beneath which is disposed a getter pump. The cold trap and getter pump are arranged in the high vacuum portion of the pump, which consists of compressor sections disposed oppositely in axial portions of the casing.

Document EP-A-0 397 051 discloses a turbomolecular pump having a rotor provided with a plurality of rotor blades and a spacer provided with a plurality of stator blades so that gas molecules are sucked in from a suction port, compressed, and discharged from an exhaust port of the turbomolecular pump. A heat exchanger is provided at the suction port side of the turbomolecular pump to freeze-trap gas molecules by cooling with a helium refrigerator. A gate valve is disposed downstream of the heat exchanger and is provided in a suction pipe that extends between the vacuum vessel and the turbomolecular pump. in an exhaust step, the gate valve is opened and, in this state, the turbomolecular pump and the helium refrigerator are run; while in a

regeneration step, the gate valve is closed, the turbomolecular pump is run, and the heat exchanger is heated by means of a heater or operation of the helium refrigerator is suspended, thereby sublimating molecules that are freeze-trapped in the heat exchanger.

Therefore, it is an object of the present invention to provide a turbo-pump with a cold trap panel that reduces the shutdown time required to vaporize accumulated water molecules on the cold trap panel, eliminates the need for a main valve in a vacuum system in which the turbo-pump is used, and increases the effective suction area of the inlet to the turbo-pump over that of the prior art.

This object is solved by the turbomolecular pump of independent claim 1 and the method of independent claim 9. Further advantageous features, aspects and details of the invention are evident from the dependent claims, the description and the drawings.

The present invention provides a turbomolecular pump having a cold trap panel that does not significantly impact the effective suction area of the turbo-pump. Additionally, a heater is positioned in an inlet to the turbo-pump, near the cold trap panel, such that, when energized, the heater quickly vaporizes any molecules absorbed by the cold trap panel. Consequently, the shutdown duration is substantially shortened as compared to the prior art and a vacuum system that employs the inventive turbo-pump does not require a main valve to isolate the pump from the vacuum chamber during the shutdown duration.

Specifically, the inventive turbo-pump contains a cold trap panel having an annular member, a disk-shaped member and a supporting frame that connects the annular member to the disk-shaped member such that these members are coaxial positioned relative to one another. The trap panel is positioned within an inlet to the turbo-pump and coaxially aligned with the main axis of an impeller thereof. Such a cold trap panel, when positioned in the inlet, has an insignificant impact on the effective suction area of the inlet to the pump.

Additionally, to significantly reduce the shutdown duration required to vaporize accumulated molecules on the cold trap panel, a heater is located proximate the trap panel such that, when energized, the heater relatively quickly vaporizes any molecules adsorbed by the trap panel. Since use of such a heater significantly reduces the shutdown duration of the turbo-pump, a vacuum system utilizing the inventive turbo-pump does not require a main valve to isolate the pump from the vacuum chamber. Furthermore, use of the inventive turbo-pump in a vacuum does not require a rotary pump to initially evacuate (rough pump) the vacuum chamber prior to using the turbo-pump. Consequently, such a vacuum system is simpler and its use is more efficient than those found in the art.

The teachings of the present invention can be readily understood by considering the following detailed description in conjunction with the accompanying drawings, in which:

FIG. 1 shows a partial sectional side view of the turbomolecular pump with a cold trap panel in accordance with the first embodiment of the invention;

FIG. 2 shows the vertical cross-sectional front view of the cold trap panel shown in FIG. 1;

FIG. 3 shows a perspective view of the cold trap panel shown in FIG. 2;

FIG. 4 depicts an illustrative vacuum system using the turbomolecular pump shown in FIG. 1;

FIG. 5 depicts an end view of the impeller and the pump case inlet and a partial sectional side view showing the effective and non-effective suction areas of the impeller of the inventive turbomolecular pump shown in FIG. 1.

FIG.6 shows a front view and a vertical cross-section of the cold trap panel showing the effective and non-effective suction areas of the cold trap panel of the inventive turbomolecular pump shown in FIG. 1;

FIG. 7 shows a partial sectional side view of the turbomolecular pump with a cold trap panel and a heater in accordance with the second embodiment of the invention;

FIG. 8 depicts an illustrative vacuum system using the inventive turbomolecular pump shown in FIG. 7;

FIG. 9 depicts another illustrative vacuum system using the inventive turbomolecular pump shown in FIG. 8.

FIG. 10 depicts a conventional vacuum system using a conventional cryogenic pump;

FIG. 11 shows a cross-sectional view of a conventional cryogenic pump; and

FIG. 12 shows a cross-sectional view of a conventional turbomolecular pump having a cold trap panel.

To facilitate understanding, identical reference numerals have been used, where possible, to designate identical elements that are common to the figures.

FIG. 1 shows a partial sectional side view of a turbomolecular pump (turbo-pump) 400 with a cold trap panel (trap panel) 414 in accordance with a first embodiment of the invention. FIG. 2 shows a vertical cross-sectional front view of the trap panel and FIG. 3 shows a perspective view of the trap panel. To best understand the first embodiment of the invention, the reader should

simultaneously view FIGs. 1, 2 and 3.

In these three figures, an impeller 406, integral with a shaft 404, is provided inside a pump case 402. Connected to one end of the pump case is an exhaust vent 408. An inlet 410 to the pump is provided on the other end of the pump case. A flange 412, for connection to a duct (not shown) that ultimately connects the pump to a vacuum chamber, is provided at the periphery of the inlet 410.

The trap panel 414 is provided at the inlet 410 of the pump case 402. The trap panel 414 contains an annular trap panel 416. The outer edges of a supporting frame 418 are securely attached to the inner circumference of the annular trap panel 416 such that individual elements of the supporting frame, when viewed from the front, orthogonally intersect at the center of the annular trap panel, forming a cross. A central trap panel 420 is centrally attached to one side of the supporting frame 418. The inner diameter of the annular trap panel 416 is approximately equal to the outer diameter of the impeller 406. The central trap panel 420 has a disc shape, which is approximately the same shape as the cross-section of shaft 404 of the impeller 406, and the diameter of the disc is approximately equal to the diameter of the shaft 404. Further, the central trap panel 420 and the shaft 404 are coaxially positioned. The annular trap panel 416, the supporting frame 418, and the central trap panel 420 are all cold panels which adsorb water molecules from the gases passing from a vacuum chamber into the pump. These units are designed to reduce the length of evacuation time by rapid elimination of water molecules.

A thermal conductor 422, made of copper and other materials of high coefficients of thermal conductivity, is connected to the annular trap panel 416 and supports it within the inlet to the pump. One end of the thermal conductor 422 is connected to a cooling unit 424 of a refrigerator 426. Through the thermal conductivity of thermal conductor 422, the refrigerator 426 cools the trap panel 414 to a low-temperature (typically, 100 degrees Kelvin). The specific low-temperature of the trap panel 414 is determined by the thermal load on the trap panel and the cooling capacity balance thereof created by the specific application of the turbo-molecular pump.

The refrigerator 426 is attached to an end of a holding case 428, which forms an integral unit with the pump case 402. Both the cooling unit 424 of the refrigerator 426 and the thermal conductor 422 are housed in the holding case 428.

In operation, when the turbo-pump 400 is driven, the rotation of the impeller 406 causes gaseous molecules in a vacuum chamber connected thereto to be drawn through the inlet 410 into the pump case 402 and discharged from the exhaust vent 408. During pumping, water molecules, which typically represent a predominant proportion of the gaseous molecules in the vacuum chamber, are condensed and frozen by the trap panel 414 at the inlet of the pump case. As such, the water molecules are eliminated from the vacuum chamber.

In use, the annular trap panel 416 is positioned proximate the periphery of the impeller 406, and the central trap panel 420 is coaxial with the main axis of the impeller. Such an arrangement ensures that the trap panel does not decrease the effective suction area of the inlet to the pump case. As such, the performance capacity of the turbo-pump is not compromised by the trap panel being located in the inlet.

FIG. 4 depicts an illustrative vacuum system 701 using the inventive turbo-pump 400 equipped with a trap panel 414 shown in FIG. 1. In FIG.4, a vacuum chamber 704 and the turbo-pump 400 equipped with a trap panel are interconnected through a duct 708 that contains a main valve 706. The turbo-pump 400 is connected to a rotary pump 712 through an auxiliary valve 710. A duct 702 protrudes from the vacuum chamber 704 through the chamber vent valve 700. A duct 716, for rough pumping the chamber, connects the chamber to the rotary pump 712. A chamber rough valve 714, located in duct 716, controls flow through that duct.

This vacuum system creates a rough vacuum in vacuum chamber 704 using the following steps: (1) closing the chamber vent valve 700; (2) opening the chamber rough valve 714; and (3) activating the rotary pump 712 in order to perform a rough evacuation of the vacuum chamber 704. Once a rough vacuum is created, rough valve 714 is closed and the exhaust vent of turbo-pump 400 is connected to the rotary pump by opening the auxiliary valve 710. Thereafter, the turbo-pump and the refrigerator for the pump's trap panel are activated. The turbo-pump reaches a constant rotational speed in a few minutes. Subsequently, the main valve 706 is opened in order to further evacuate the vacuum chamber 704. After approximately one hour, the trap panel 704 attains a constant cryogenic temperature that is sufficiently cold to trap water molecules. The result is a secondary evacuation of the vacuum chamber.

The improved nature of the inventive turbo-pump over the prior art can be readily understood with reference to FIGs. 5 and 6. In FIG. 5, "a" denotes the size of an area (effective suction area) through which a vane for the impeller 406 rotates, and "b" denotes the size of an area (non-effective suction area) of the shaft 404, which does not contain a vane. As such, "a" represents the size of an area of the pump inlet that actually produces suction, while "b" represents the size of an area of the pump that does not produce suction. In FIG. 6, "al" denotes the size of an area (effective suction area) of a space containing the annular trap panel 416, "bl" denotes the size of an area (non-effective area) containing the central trap panel 420. Since the trap panel is positioned directly in front of the pump inlet, it stands to reason that the maximum evacuation conductance for the turbo-pump is attained when: area "al" $\geq$ area "a" and area "bl" $\leq$ area "b" (provided that the trap panel 414 and the impeller 406 are coaxial and in close proximity to one another). As such, the trap panel of the structure

in the present embodiment can easily attain the size relationships $a1 \geq a$ and $b1 \leq b$, and, therefore, can maximize the effective area of the trap panel without significantly reducing the effective suction area of the pump inlet.

Although in this embodiment, the trap panel 414 is a contiguous annular ring, the present invention is not limited to only this configuration. Alternatively, sector-shaped panels (portions of a non-contiguous ring), each attached to an individual element of the support frame and arranged in ring form, can produce the same cold trap effect without significantly impacting the effective suction area of the pump inlet.

As explained above, in the turbo-pump equipped with a trap panel, a trap panel is provided in such a way that the effective suction area of inlet of the turbo-pump is not significantly diminished. This configuration maximizes the conductance and eliminates the need for enlarging the gas inlet in order to compensate for the space occupied by the trap panel. The result is a cold trap panel that does not significantly impact the performance characteristics of the turbo-pump to which it is connected.

In a second embodiment of the inventive turbo-pump depicted in FIG. 7, a heater 1002, consisting of a heating coil, is provided between the trap panel 414 and the inlet 410 of the pump case 402. The purpose of the heater 1002 is to rapidly evaporate the water molecules adsorbed on the trap panel 414 through the application of external energy. Therefore, the heater 1002 can be configured and arranged in any way that effectively evaporates the water molecules and should not be construed as being limited to the specific configuration and arrangement shown in FIG. 7. For instance, the heater may be an electrical heating coil, a coil of tubing carrying a heated liquid, a plurality of infrared heating elements, and the like.

FIG. 8 shows a turbo-pump 1000 of the second embodiment of the present invention as used in an illustrative vacuum system 1100. Importantly, a duct 708 directly interconnects the vacuum chamber 704 with the turbo-pump 1000, i.e., a main valve is not used. The turbo-pump 1000 is connected to a rotary pump 712 through an auxiliary valve 710. A duct 702 protrudes from the vacuum chamber 704 through a chamber vent valve 700.

Evacuation using the vacuum system of FIG.8 is performed by closing the chamber vent valve 700, opening the auxiliary valve 710, and running the rotary pump 712 in order to perform a rough evacuation inside the vacuum chamber 704. Simultaneously, the turbo-pump 1000 and the refrigerator for the pump's trap panel are activated. The turbo-pump, upon reaching a constant rotational speed, further evacuates the interior of the vacuum chamber 704. Approximately one hour later, the trap panel reaches a constant cryogenic temperature and the vacuum chamber 704 attains a high vacuum.

When the turbo-pump 1000 with trap panel is driven, the rotation of the impeller vanes cause the gaseous molecules in the vacuum chamber to be drawn, through the inlet, into the pump case and discharged from the exhaust vent. Additionally, during pumping, water molecules, which represent a predominant proportion of the gaseous molecules, are condensed and frozen at the entrance of the pump case by the trap panel. The result is an efficient evacuation of the vacuum chamber.

Upon completion of an operation (e.g., a sputtering process) under vacuum in the vacuum chamber, it is generally necessary to open the chamber vent valve in order to vent the vacuum chamber to atmospheric pressure. Typically, to most efficiently utilize the vacuum system, it is desirable to have access to the interior of the vacuum chamber as quickly as possible after the processing is completed within the chamber. As such, to facilitate such quick access without the use of a main valve, the temperature of the trap panel of the turbo-pump must be quickly raised from the cryogenic temperature (approximately 100 degrees Kelvin) to ordinary room temperature (approximately 300 degrees Kelvin). However, if air is allowed to enter the turbo-pump when the pump is still at the cryogenic temperature, the water molecules adsorbed on the trap panel, in the form of ice, are rapidly gasified or liquefied, and detrimentally flow into the vacuum chamber. To avoid this problem, conventionally either a main valve is used or the trap panel is slowly warmed from the cryogenic temperature to room temperature before the vacuum is released from the chamber in a process that takes about one hour. However, according to this embodiment of the invention, the provision of the heater in close proximity to the inlet of the turbo-pump permits warming of the trap panel from the cryogenic temperature to room temperature in a relatively short duration of several minutes, e.g., approximately ten (10) minutes. While the heater vaporizes the adsorbed water molecules, the impeller draws the evaporated water molecules into the pump and away from the vacuum chamber. When the trap panel attains room temperature, the auxiliary valve 710 is closed, the turbo-pump 1000 is simultaneously deactivated, and the chamber vent valve 700 is opened, and then the vacuum chamber 704 is vented in order to bring the pressure inside the vacuum chamber to atmospheric pressure.

Using the heater of the present invention, it takes about 10 minutes before venting of the vacuum chamber can be commenced. Typically, in a conventional system having a main valve, this ten minute waiting period is not necessary because the main valve is used to isolate the vacuum chamber from the pump. However, the waiting period is necessary precondition to the elimination of the main valve, and, as discussed above, the elimination of the main valve yields significant advantages.

FIG. 9 depicts another vacuum system 1200 in which the inventive turbo-pump 1000 shown in FIG. 7 is used. Here, in contrast to the vacuum system shown in FIG. 8, a rotary pump is not used to initially evacuate the vacuum chamber 704 prior to using the turbo-pump.

Specifically, as shown in FIG. 9, the exhaust vent of the turbo-pump 1000 is connected through valve 710 to the atmosphere. As such, turbo-pump 1000 directly evacuates the vacuum chamber, i.e., without the use of a rough pump to initially evacuate the vacuum chamber. Additionally, as described above, the heater and cold trap panel in the turbo-pump 1000 permit the pump to be directly connected to the vacuum chamber by duct 708. Consequently, the vacuum system 1200 is significantly simplified as compared to the prior art.

As stated above, the evacuation system of this invention is capable of eliminating gaseous molecules through the use of a turbomolecular pump. Through the use of a trap panel, it can also eliminate water molecules, which represent a predominant proportion of the gaseous molecules contained in a vacuum chamber. The inventive design of the trap panel ensures that the turbo-pump maintains a relatively high conductance though fitted with a trap panel at its inlet. Further, the heater provided at the inlet quickly vaporizes and eliminates the water molecules that condense on the trap panel, thus reducing the length of time that the turbo-pump requires for shutdown. The result is improved operational efficiency of a vacuum system that utilizes the inventive turbo-pump. Further, the reduction in turbo-pump shutdown duration permits the turbo molecular pump to be directly connected to the vacuum chamber. This advantageously permits eliminating the conventional main valve in the vacuum system.

Although various embodiments which incorporate the teachings of the present invention have been shown and described in detail herein, those skilled in the art can readily devise many other varied embodiments that still incorporate these teachings.

In general terms, the invention provides a turbo-pump equipped with a trap panel, in which an impeller integrated with the main axis is housed in the pump case, and in which a trap panel is provided at the inlet of the pump case; the said turbo-pump equipped with a trap panel characterized in that the trap panel is positioned at the center of two ring-shaped trap panels, that the trap panel is composed of a central trap panel supported by the ring-shaped trap panels through the use of a supporting frame, such that the central trap panel and the main axis are positioned on the same axial line.

The invention further provides the turbo-pump equipped with a trap panel , characterized in that if "a" denotes the size of the effective suction unit between the end of the impeller and the main axis, "b" denotes the diameter of the main axis, "a1" denotes the size measured from the outer circumference of the central trap panel to the inner circumference of the ring-shaped trap panels, and "b1" denotes the diameter of the central trap panel, then the following relationships hold: $a1 \fallingdotseq a$, $b1 \fallingdotseq b$.

According to another aspect, the invention provides a vacuum evacuation device that evacuates the gas in a vacuum chamber by means of a vacuum pump, wherein said vacuum evacuation device is characterized in that the aforementioned vacuum pump comprises a turbo-pump, equipped with a trap panel that possesses a heating device in the air intake.

According to a further aspect, the invention provides the vacuum evacuation device , which is characterized in that it is structured such that the aforementioned turbo-pump equipped with a trap panel is directly connected to the vacuum chamber via a conduit.

Furthermore, the invention teaches to replace the conventional high-vacuum pump (oil diffusion pump, turbo-pump, cryo-pump) and low-vacuum pump (rotary oil pump, various types of dry pumps) with a turbo-type dry pump, and an H_2O trap is added.

Also by using the type of turbo-type dry pump and trap that can be started up or shut down in a few minutes, the main valve becomes unnecessary.

The high-vacuum pump and low-vacuum pump and main valve combination can be replaced with a trap and turbo-type dry pump, resulting in simpler design, smaller size and lower cost.

This invention can be utilized in various high-vacuum equipment, such as evaporation systems, vacuum smelting systems, CVD systems, etc.

Claims

1. A turbomolecular pump (300;400;1000) comprising a pump casing (302;402) supporting an impeller (310;406) having a shaft (306;404) aligned with a main axis, wherein, upon rotation of the impeller (310;406), gaseous molecules proximate an inlet port (323;410) to the pump casing (302;402) are drawn into the pump casing (302;402) and exhausted therefrom through an exhaust vent (312;408) of the pump casing (302;402), apparatus comprising:

   means (314,316,318,320;414,416,418,420, 422,424,426,428) positioned proximate said inlet port (323;410) of said pump casing (302; 402), for adsorbing certain molecules;

   said adsorbing means comprising an annular panel (416) having a diameter defined by an inner surface, a disk-shaped panel (420) having a diameter that is less than said diameter of said annular panel (416), and a support frame (418), connected between said disk-shaped panel (420) and said annular panel (416), such that said disk-shaped panel (420) and said annular panel (416) are coaxially positioned relative one another.

2. The turbomolecular pump according to claim 1 further comprising means (1002), positioned proximate said adsorbing means, for heating said adsorbing means.

3. The turbomolecular pump according to any one of the preceding claims further comprising means (320;422,424,426,428) for cooling said adsorbing means.

4. The turbomolecular pump according to any one of the preceding claims wherein said adsorbing means is coaxially aligned with said main axis.

5. The turbomolecular pump according to any one of the preceding claims wherein said diameter of said annular panel (416) is substantially equivalent to or greater than a diameter of said impeller (310;406).

6. The turbomolecular pump according to any one of the preceding claims wherein said diameter of said disk-shaped panel (420) is substantially equivalent to or less than a diameter of said shaft (306;404).

7. The turbomolecular pump according to any one of claims 2 to 6 wherein said heating means further comprises an electric heating coil (1002).

8. The turbomolecular pump of claim 7 wherein said electric heating coil (1002) circumscribes said inlet port (323;410).

9. A method for driving a vacuum system, said vacuum system comprising:

a vacuum chamber

a turbomolecular pump (300;400;1000) directly connected to said vacuum chamber, wherein said turbomolecular pump comprises:

a pump casing (302;402) supporting an impeller (310; 406) having a shaft (306;404) aligned along a main axis, wherein, upon rotation of the impeller (310;406), gaseous molecules proximate an inlet port (323; 410) to the pump casing (302;402) are drawn into the pump casing and exhausted therefrom through an exhaust vent (312; 408) of the pump casing (302;402),

means (314,316,318,320,414,416,418,420,422,424,426,428) positioned proximate said inlet port (323;410) of said pump casing (302;402), for adsorbing certain molecules;

said adsorbing means comprising an annular panel (416) having a diameter defined by an inner surface, a disk-shaped panel (420) having a diameter that is less than said diameter of said annular panel (416), and a support frame (418), connected between said disk-shaped panel (420) and said annular panel (416), such that said disk-shaped panel (420) and said annular panel (416) are coaxially positioned relative one another;

means (1002), positioned proximate said adsorbing means, for heating said adsorbing means; and

a chamber vent valve (710), comprising the steps of:

a. applying external energy to the heating means for heating said adsorbing means,

b. waiting until the adsorbing means reaches a predetermined temperature, and

c. opening the chamber vent valve in order to vent the vacuum chamber to atmospheric pressure.

Patentansprüche

1. Turbomolekularpumpe (300; 400; 1000) mit einem Pumpengehäuse (302; 402), welches ein Flügelrad (310; 406) mit einer Welle (306; 404), ausgerichtet mit einer Hauptachse, stützt, wobei bei Drehung des Flügelrades (310; 406) Gasmoleküle in der Nähe einer Einlaßöffnung (323; 410) zum Pumpengehäuse (302; 402) in das Pumpengehäuse (302; 402) eingesaugt werden und durch eine Austrittsöffnung (312; 408) des Pumpengehäuses (302; 402) hiervon austreten, wobei die Vorrichtung folgendes aufweist:

ein Mittel (314,316,318,320;414,416,418, 420,422,424,426,428) in der Nähe der Einlaßöffnung (323; 410) des Pumpengehäuses (302; 402), zur Adsorption bestimmter Moleküle;

wobei das Adsorbiermittel ein ringförmiges Paneel (416) mit einem Durchmesser, welcher durch eine Innenoberfläche definiert ist, ein scheibenförmiges Paneel (420) mit einem Durchmesser, welcher kleiner als der Durchmesser des ringförmigen Paneels (416) ist, und einen Stützrahmen (418), welcher zwischen dem scheibenförmigen Paneel (420) und dem ringförmigen Paneel (416) verbunden ist, so daß das scheibenförmige Paneel (420) und das ringförmige Paneel (416) relativ zueinander koaxial positioniert sind, aufweist.

2. Turbomolekularpumpe gemäß Anspruch 1, die des weiteren ein Mittel (1002) in der Nähe des Adsorbiermittels zum Erwärmen des Adsorbiermittels aufweist.

3. Turbomolekularpumpe gemäß einem der vorhergehenden Ansprüche, die des weiteren Mittel (320; 422, 424, 426, 428) zum Kühlen des Adsorbiermittels aufweist.

4. Turbomolekularpumpe gemäß einem der vorhergehenden Ansprüche, bei der das Adsorbiermittel koaxial mit der Hauptachse ausgerichtet ist.

5. Turbomolekularpumpe gemäß einem der vorhergehenden Ansprüche, bei der der Durchmesser des ringförmigen Paneels (416) im Vergleich zu einem Durchmesser des Flügelrads (310; 406) im wesentlichen gleich oder größer ist.

6. Turbomolekularpumpe gemäß einem der vorhergehenden Ansprüche, bei der der Durchmesser des scheibenförmigen Paneels (420) im Vergleich zu einem Durchmesser der Welle (306; 404) im wesentlichen gleich oder geringer ist.

7. Turbomolekularpumpe gemäß einem der Ansprüche 2 bis 6, bei der das Erwärmungsmittel des weiteren eine elektrische Heizspule (1002) aufweist.

8. Turbomolekularpumpe gemäß Anspruch 7, bei der die elektrische Heizspule (1002) die Einlaßöffnung (323; 410) begrenzt.

9. Verfahren zum Antrieb eines Vakuumsystems, wobei das Vakuumsystem folgendes aufweist:

eine Vakuumkammer

eine direkt mit der Vakuumkammer verbundene Turbomolekularpumpe (300; 400; 1000), wobei die Turbomolekularpumpe folgendes aufweist:

ein Pumpengehäuse (302; 402), welches ein Flügelrad (310; 406) mit einer Welle (306; 404), ausgerichtet entlang einer Hauptachse, stützt, wobei bei Drehung des Flügelrades (310; 406) Gasmoleküle in der Nähe einer Einlaßöffnung (323; 410) zum Pumpengehäuse (302; 402) in das Pumpengehäuse (302; 402) eingesaugt werden und durch eine Austrittsöffnung (312; 408) des Pumpengehäuses (302; 402) hiervon austreten,

ein Mittel (314,316,318,320,414,416,418, 420,422,424,426,428) in der Nähe der Einlaßöffnung (323; 410) des Pumpengehäuses (302; 402), zur Adsorption bestimmter Moleküle;

wobei das Adsorbiermittel ein ringförmiges Paneel (416) mit einem Durchmesser, welcher durch eine Innenoberfläche definiert ist, ein scheibenförmiges Paneel (420) mit einem Durchmesser, welcher kleiner als der Durchmesser des ringförmigen Paneels (416) ist, und einen Stützrahmen (418), welcher zwischen dem scheibenförmigen Paneel (420) und dem ringförmigen Paneel (416) verbunden ist, so daß das scheibenförmige Paneel (420) und das ringförmige Paneel (416) relativ zueinander koaxial positioniert sind, aufweist;

ein Mittel (1002) in der Nähe des Adsorbiermittels zum Erwärmen des Adsorbiermittels; und

ein Kammerlüftungsventil (710), mit folgenden Schritten:

a. Anlegen von externer Energie an das Erwärmungsmittel zum Erwärmen des Adsorptionsmittels,

b. Warten, bis das Adsorptionsmittel eine vorbestimmte Temperatur erreicht, und

c. Öffnen des Kammerlüftungsventils zur Lüftung der Vakuumkammer auf Atmosphärendruck.

Revendications

1. Pompe turbomoléculaire (300; 400; 1000) comprenant un carter de pompe (302; 402) supportant une roue à aubes (310; 406) comprenant un axe (306; 404) aligné avec un axe principal, dans laquelle, lors de la rotation de la roue à aubes (310; 406), les molécules gazeuses se trouvant a proximité d'un orifice d'entrée (323; 410) vers le carter de pompe (302; 402) sont aspirées dans le carter de pompe (302; 402) et évacuées de celui-ci au travers d'un évent de sortie (312; 408) du carter de pompe (302; 402), l'appareil comprenant :

des moyens (314, 316, 318, 320; 414, 416, 418, 420, 422, 424, 426, 428) positionnés à proximité dudit orifice d'entrée (323; 410) dudit carter de pompe (302; 402), pour adsorber certaines molécules ;
lesdits moyens d'adsorption comprenant un

panneau annulaire (416) ayant un diamètre défini par une surface intérieure, un panneau en forme de disque (420) ayant un diamètre inférieur audit diamètre dudit panneau annulaire (416) et une structure de support (418) connectant ledit panneau en forme de disque (420) audit panneau annulaire (416), de sorte que ledit panneau en forme de disque (420) et ledit panneau annulaire (416) sont positionnés de manière coaxiale l'un par rapport à l'autre.

2. Pompe turbomoléculaire selon la revendication 1, comprenant en outre des moyens (1002) positionnés au voisinage desdits moyens d'adsorption pour chauffer lesdits moyens d'adsorption.

3. Pompe turbomoléculaire selon l'une quelconque des revendications précédentes, comprenant en outre des moyens (320; 422, 424, 426, 428) pour refroidir lesdits moyens d'adsorption.

4. Pompe turbomoléculaire selon l'une quelconque des revendications précédentes, dans laquelle les moyens d'adsorption sont coaxiaux avec ledit axe principal.

5. Pompe turbomoléculaire selon l'une quelconque des revendications précédentes, dans laquelle ledit diamètre dudit panneau annulaire (416) est sensiblement équivalent ou supérieur à un diamètre de ladite roue à aubes (310; 406).

6. Pompe turbomoléculaire selon l'une quelconque des revendications précédentes, dans laquelle ledit diamètre dudit panneau en forme de disque (420) est sensiblement équivalent ou inférieur à un diamètre dudit axe (306; 404).

7. Pompe turbomoléculaire selon l'une quelconque des revendications 2 à 6, dans laquelle lesdits moyens de chauffage comprennent en outre une bobine électrique de chauffage (1002).

8. Pompe turbomoléculaire selon la revendication 7, dans laquelle ladite bobine électrique de chauffage (1002) circonscrit ledit orifice d'entrée (323; 410).

9. Procédé d'entraînement d'un système d'aspiration, ledit système d'aspiration comprenant :

une chambre d'aspiration ;
une pompe turbomoléculaire (300; 403; 1000) directement connectée à ladite chambre d'aspiration, ladite pompe turbomoléculaire comprenant
un carter de pompe (302; 402) supportant une roue à aubes (310; 406) comprenant un axe (306;404) aligné avec un axe principal, dans laquelle, lors de la rotation de la roue à aubes (310; 406), les molécules gazeuses se trouvant à proximité d'un orifice d'entrée (323; 410) vers le carter de pompe (302; 402) sont aspirées dans le carter de pompe et évacuées de celui-ci au travers d'un évent de sortie (312; 408) du carte de pompe (302;402),
des moyens (314, 316, 318, 320; 414, 416, 418, 420, 422, 424, 426, 428) positionnés à proximité dudit orifice d'entrée (323; 410) dudit carter de pompe (302; 402), pour adsorber certaines molécules ;
lesdits moyens d'adsorption comprenant un panneau annulaire (416) ayant un diamètre défini par une surface intérieure, un panneau en forme de disque (420) ayant un diamètre inférieur audit diamètre dudit panneau annulaire (416) et une structure de support (418) connectant ledit panneau en forme de disque (420) audit panneau annulaire (416), de sorte que ledit panneau en forme de disque (420) et ledit panneau annulaire (416) sont positionnés de manière coaxiale l'un par rapport à l'autre ;
des moyens (1002) positionnés au voisinage desdits moyens d'adsorption pour chauffer lesdits moyens d'adsorption ; et
une vanne de dégazage de chambre (710),

comprenant les étapes consistant :

1. à appliquer une énergie externe aux moyens de chauffage, pour chauffer lesdits moyens d'adsorption,
2. à attendre que les moyens d'adsorption aient atteint une température prédéterminée, et
3. à ouvrir la vanne de dégazage de la chambre afin de dégazer la chambre d'aspiration jusqu'à la pression atmosphérique.

Fig. 1

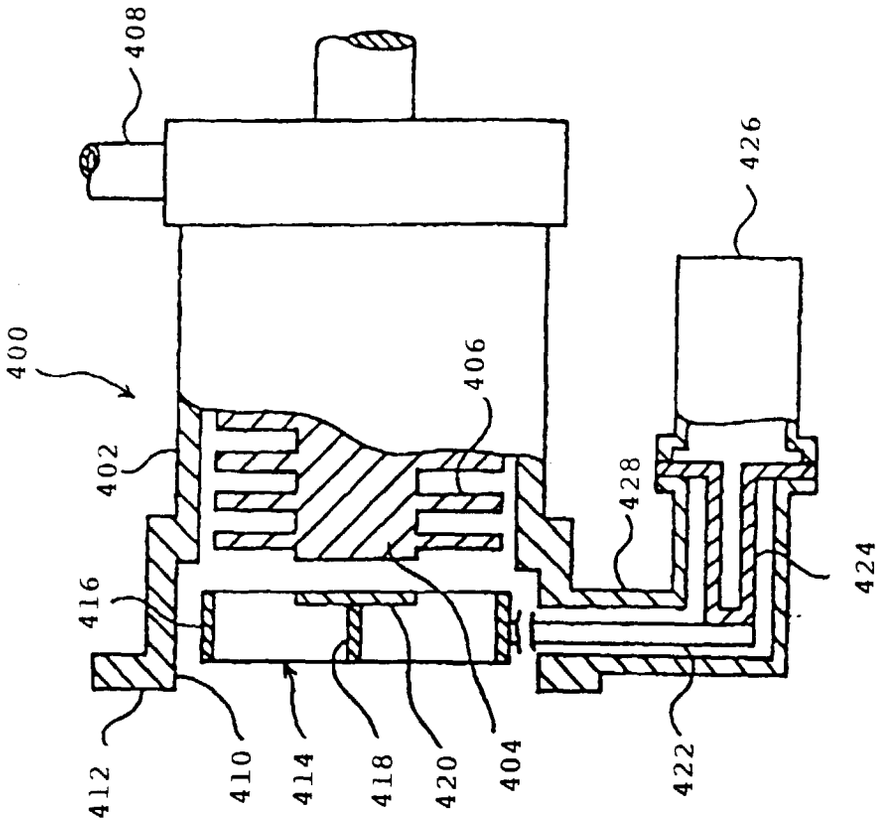
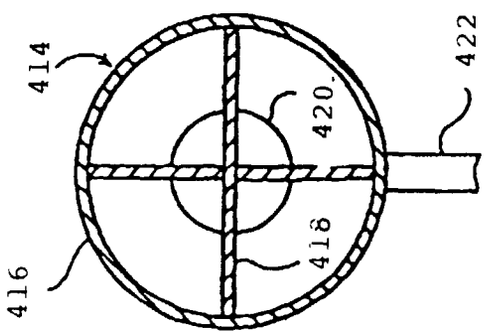

408
426
400
406
402
428
416
424
412
410
414
418
420
404
422

Fig. 2


414
422
420
418
416

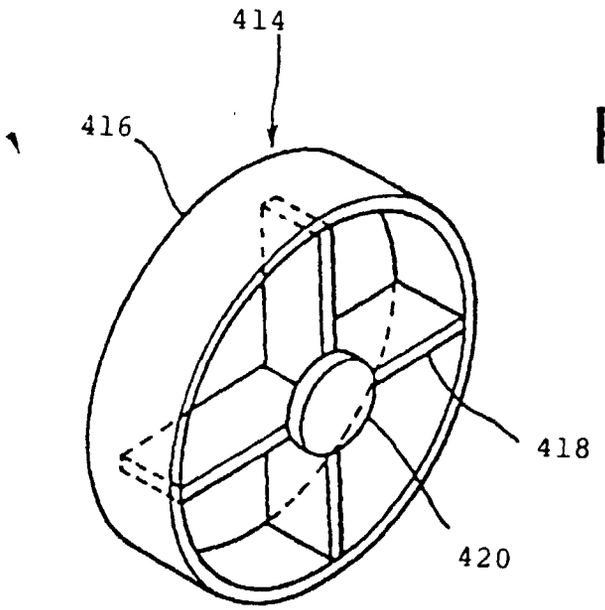

414
416
418
420

Fig. 3

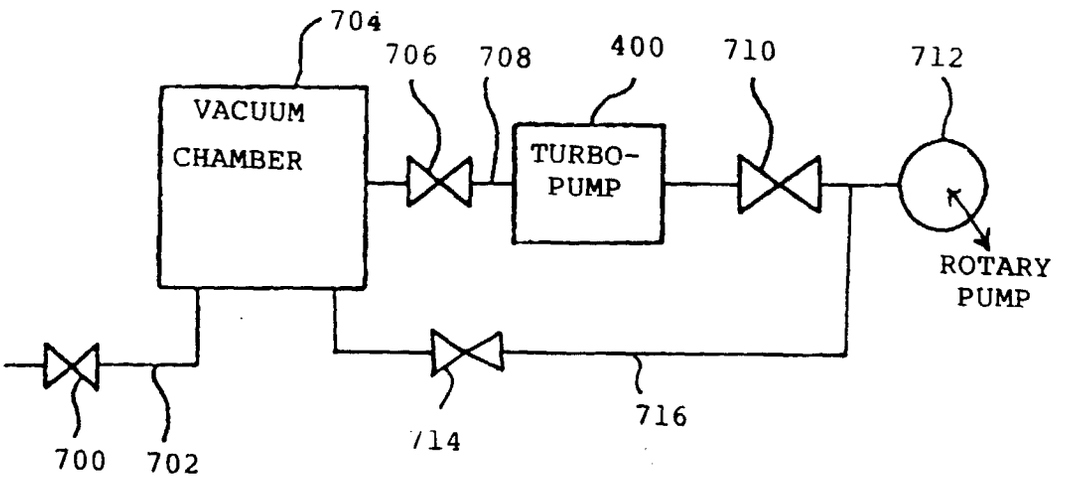
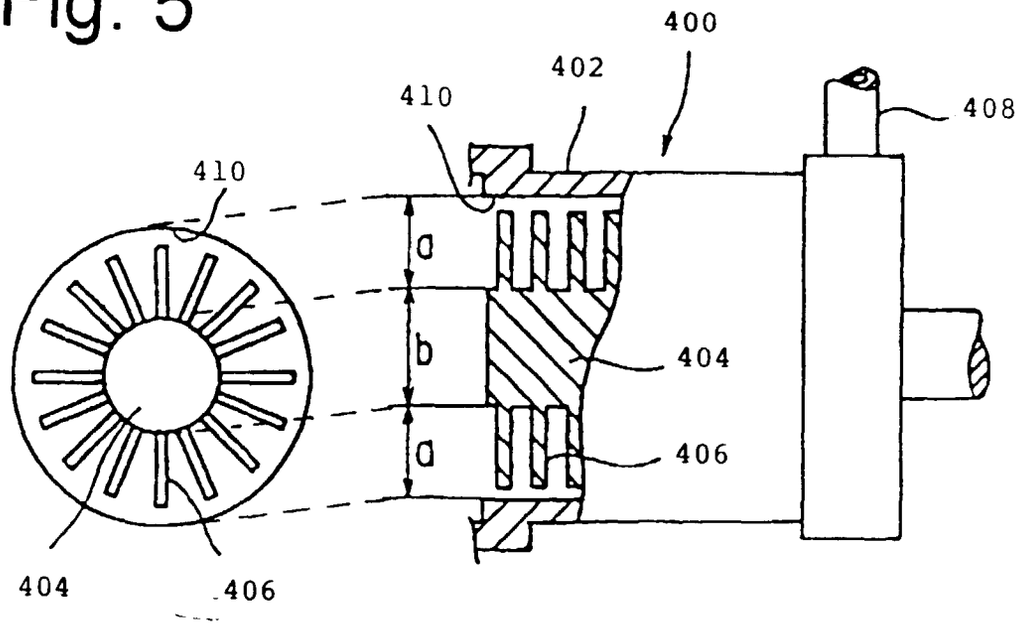

704
706
708
400
710
712
VACUUM
CHAMBER
TURBO-
PUMP
ROTARY
PUMP
700
702
714
716

Fig. 4

Fig. 5


400
402
410
408
410
a
b
404
a
406
404
406

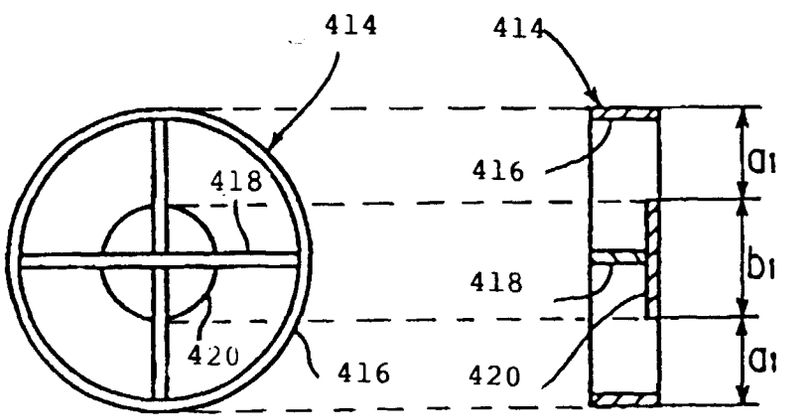

414
414
418
416
a1
418
b1
420
416
420
a1

Fig. 6

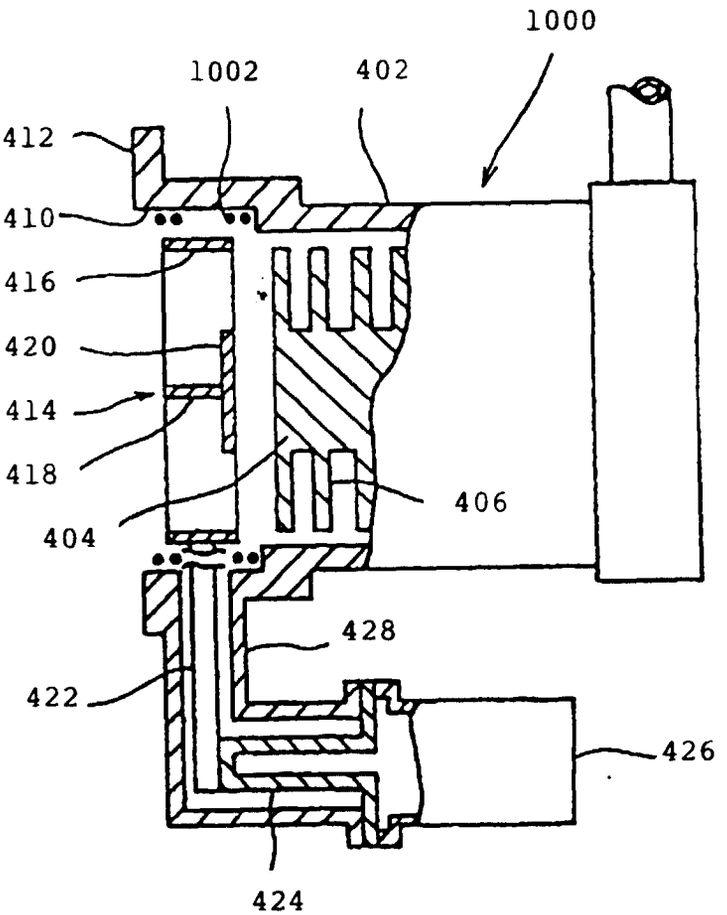


Fig. 7

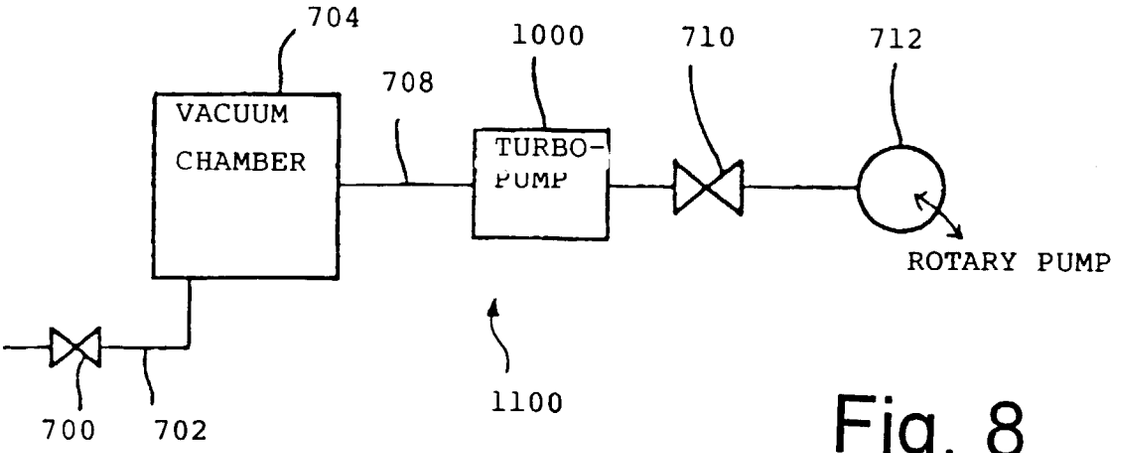

704
1000
710
712
708
VACUUM
CHAMBER
TURBO-
PUMP
ROTARY PUMP
700
702
1100

Fig. 8

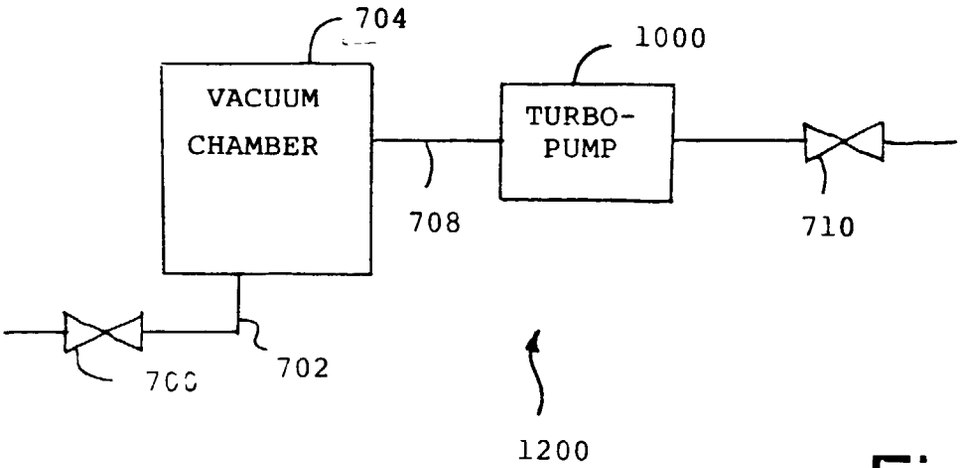
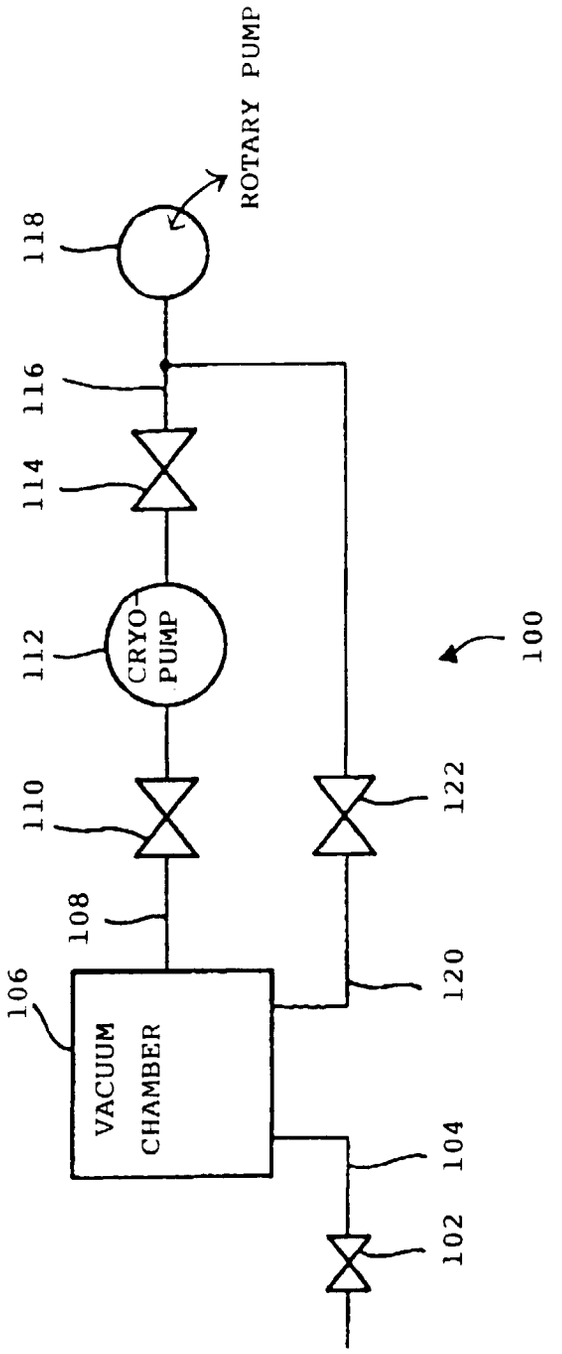

704
1000
VACUUM
CHAMBER
TURBO-
PUMP
708
710
700
702
1200

Fig. 9

Fig. 10


ROTARY PUMP
118
116
114
CRYO PUMP
112
110
108
106
VACUUM CHAMBER
120
122
100
104
102

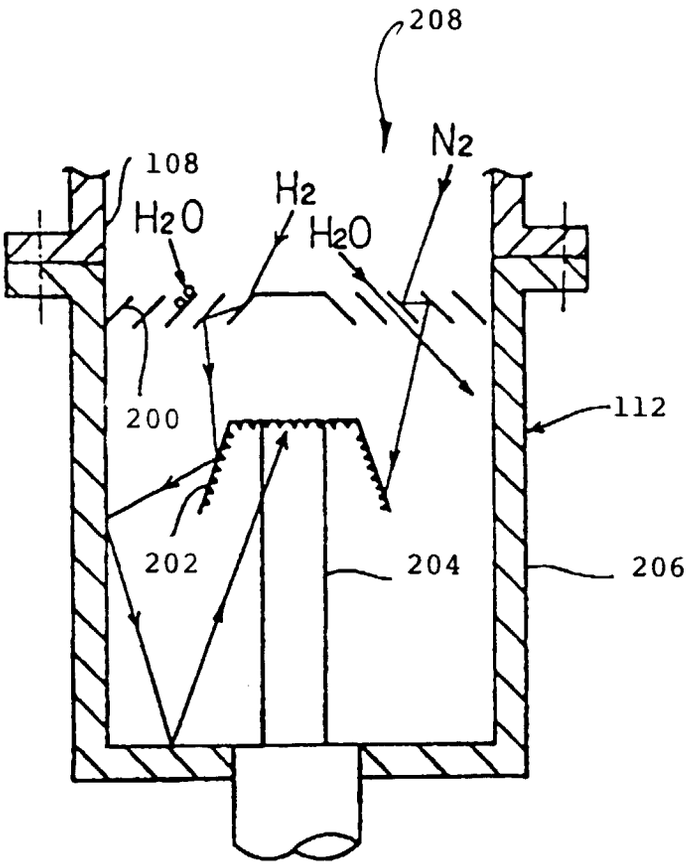


Fig. 11

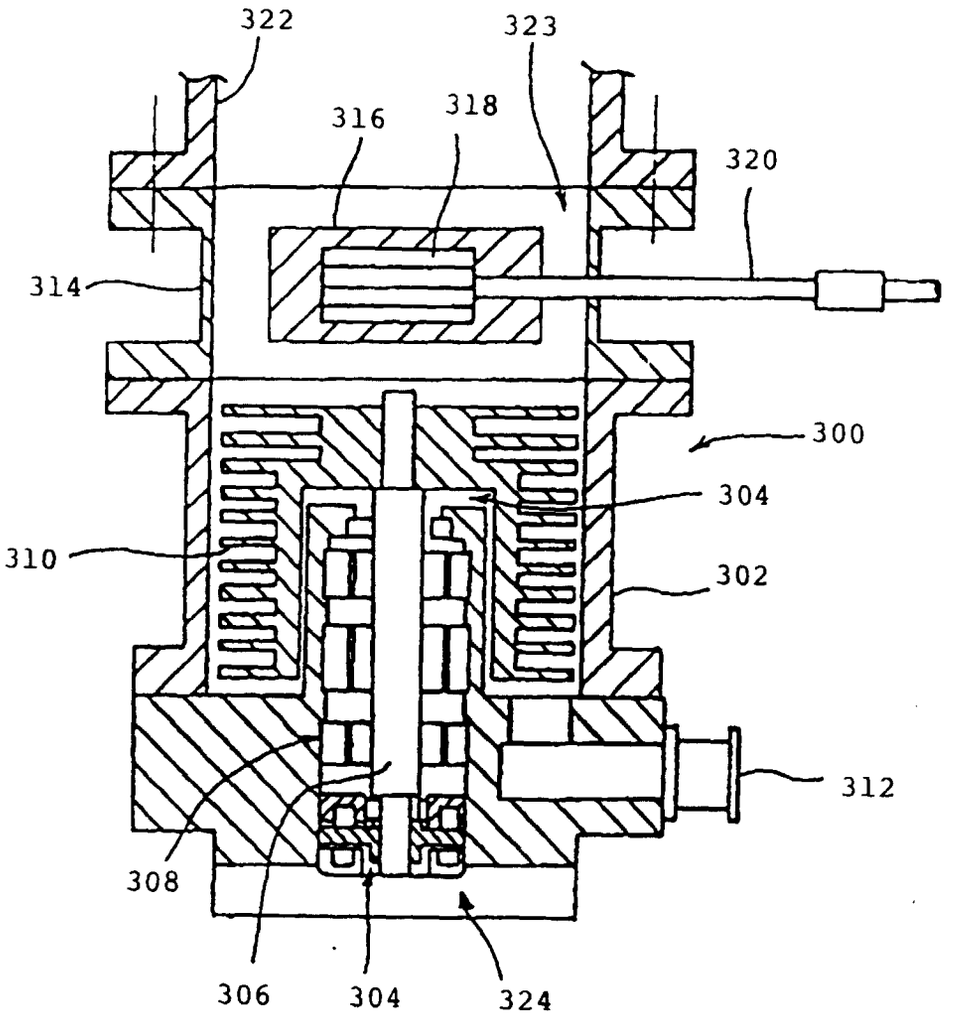


Fig. 12